

IRW

AMENDMENT TRANSMITTAL LETTER

Docket No.
FIS920030286US1

Application No.
10/605,889

Filing Date
11/04/03

Examiner
Long Pham

Art Unit
2814

Applicant(s): **Michael P. Belyansky et al.**

Invention: **OXIDATION METHOD FOR ALTERING A FILM STRUCTURE AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH**

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	20	30			
Independent Claims	2	3			
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					

☒ Large Entity

☐ Small Entity

☒ No additional fee is required for this amendment.

☐ Please charge Deposit Account No. _____ in the amount of \$ _____.
A duplicate copy of this sheet is enclosed.

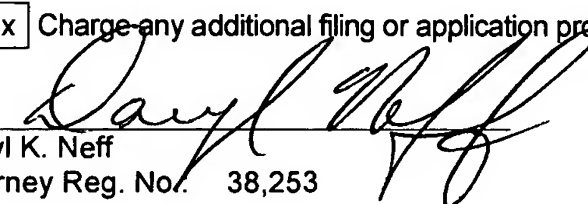
☐ A check in the amount of \$ _____ to cover the filing fee is enclosed.

☐ Payment by credit card. Form PTO-2038 is attached.

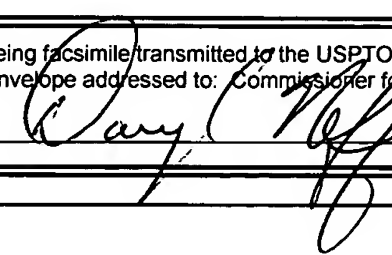
☒ The Director is hereby authorized to charge and credit Deposit Account No. **09-0458** as described below. A duplicate copy of this sheet is enclosed.

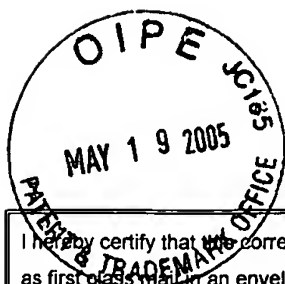
☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.


Daryl K. Neff
Attorney Reg. No. 38,253

Dated: May 16, 2005

I hereby certify that this correspondence is being facsimile/transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.
Dated: May 16, 2005 Signature:  (Daryl K. Neff)



I hereby certify that the correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: MS Amendment, Commissioner for Patents, Alexandria, VA 22313-1450 on this date: May 16, 2005

Name of Depositor: Daryl K. Neff

Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Michael P. Belyansky, et al.	Date: May 16, 2005
Serial Number: 10/605,889	Examiner: Long Pham
Filed: November 4, 2003	Group Art Unit: 2814
Title: OXIDATION METHOD FOR ALTERING A FILM STRUCTURE AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH	IBM Corporation D/18G, B/300, Zip 482 2070 Route 52 Hopewell Junction, NY 12533-6531

AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated February 16, 2005, Applicants submit the following amendments and remarks.

FIS920030286US1